

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/664,271	<b>Applicant(s)/Patent under Reexamination</b> LIU, KAIPING
	<b>Examiner</b> Edward Wojciechowicz	<b>Art Unit</b> 2815

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner